



**INTERNATIONAL
GEMOLOGICAL
INSTITUTE**

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

October 18, 2024	
IGI Report Number	LG660456677
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	SQUARE EMERALD CUT
Measurements	8.88 X 8.70 X 5.74 MM

GRADING RESULTS

Carat Weight	4.06 CARATS
Color Grade	E
Clarity Grade	VS 1

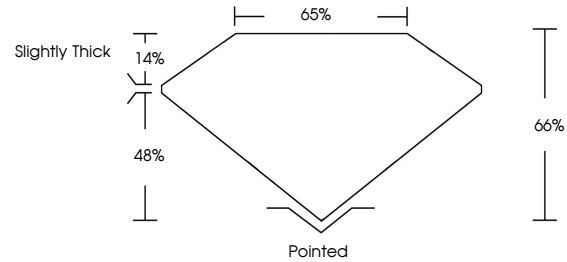
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	 LG660456677

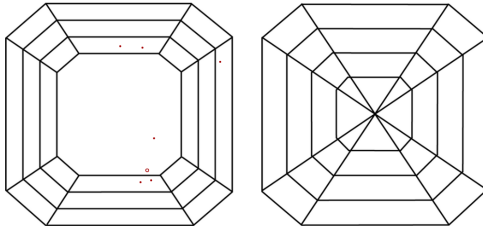
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG660456677
Report verification at igi.org

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

CLARITY

IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	151 LG660456677
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.	
Type IIa	



IGI

October 18, 2024	Carat Weight	4.06 CARATS
IGI Report No. LG4065677	Color Grade	E
SQUARE HERALD CUT	Clarity Grade	VS 1
8.89 X 8.70 X 5.74 MM	Depth	66%
	Table	65%
	Girdle	Slightly Thick
	Culet	Pointed
	Polish	EXCELLENT
	Symmetry	EXCELLENT
	Fluorescence	NONE
	Inscription(s)	691 LG4065677
Comments: This is a Very Good Diamond was certified by IGI and created by Chemical Vapor Deposition (CVD) growth process.		
Type IIa		

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Type IIa

www.igi.org

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